Ultra-Intense Lasers II



Design, technology proospects



CPA technique





CPA





Generation of UHI laser pulses



- Need to have a laser medium with sufficient bandwidth to support short pulses
- Need to provide save amplification without hig B- Integral
- Need to provide high contrast not to destroy the sample too early
- Need to be efficient and high rep rate
- Need to be compact

•

Materials (Examples)

Laser Materials requirements:

- Right wavelength ($I\lambda^2$ scaling)
- Lasing cross section stored energy, gain, fluence limit
- Bandwidth
- Optical Quality
- Thermal properties
- Matching with pump sources

Each laser material consist of a host material and an active (lasing) material

Requirements:

Mechanical, chemical and optical properties

hard inert no innerer stress and variations of n

Good to shape

Host lattice structure must accompany guest atoms without disturbing the optical properties

P



Ti:Saphir (1)

 $\mathsf{Ti:Al}_2O_3$

Mostly used, tunable soliid state laser for short pulses.

Tuning range 400 nm.

Energy levels of Ti unique in transition metals:

Czochralski crystal growth, doped with Sapphire at 0.1% Ti³⁺ weigth percent.

Broad absorption spectrum, peaks at 490 nm.

Broad Vibrational-Fluorescence spectrum with lasing between 670 – 1070 nm with peak at 800 nm.





Ti:Saphir (2)



Index of refraction	1.76		
Fluorescent lifetime	3.2 µs		
Fluorescent linewidth (FWHM)	180 nm		
Peak emission wavelength	790 nm		
Peak stimulated emission cross section			
parallel to c-axis	$\sigma_{\parallel} \sim 4.1 \times 10^{-19} \mathrm{cm}^2$		
perpendicular to c-axis	$\sigma_{\perp} \sim 2.0 \times 10^{-19} {\rm cm}^2$		
Stimulated emission cross section			
at 0.795 µm (parallel to c-axis)	$\sigma_{\parallel} = 2.8 \times 10^{-19} \mathrm{cm}^2$		
Quantum efficiency of			
converting a 0.53 μ m pump photon			
into an inverted site	$\eta_{\rm O} \approx 1$		
Saturation fluence at 0.795 μ m	$E_{\rm s} = 0.9 {\rm J/cm^2}$		
	NUN		

Further advantages:

High heat conductivity, exceptional chemical toughness, hard Ti:Sa are pumped by Argon ion- and frequency-doubled ND:YAG and ND:YLF lasers and recently even with ND:glass lasers.

Ti:Saphir (3)



Short fluorescence lifetime: 3.2µs : high pump power required!

Most important application: Kerr-lens mode locking for generation of ultra-short pulses (6 fs) and their amplification (CPA-Systems).



Laser material (1) Nd:Glas



Almost all high energy laser systems are made of Nd:glass

Reasons:

- 1. The absorption spectrum of Nd³⁺ in typical optical glasses goes from \approx 350 nm in the UV to \approx 900 nm in the infrared: overlap with cheap optical pump sources, like. Xe-flash lamps.
- 2. Laser wavelength of 1.06µm is of interest to laser fusion with acceptable coupling efficiency
- 3. By combining important energy levels large amoungs of eenergy can be stored at 1.06µm
- 4. Cross section for induced emission is in medium range: high enough for good gain at reasonable spatial scale small enough to handle ASE effects.
 (ASE we deal with later)
- Properties of Nd³⁺ are well known: High predictive capability on systems and performance. Technologie of making the material is state of the art and can be tailored (High Average Power, High Bandwidth).

Laser material (2) Nd:Glas



Downside:

- 1. Efficiency: Typical amplifier only convert 0.5-3% of electrical energy into laser radiation.
- Low thermal conductivity and low efficiency : lots of energy lost in heat low repetition rate. Typical laser systems operate only once in 0.5-3 hours.

Lasermaterialien (3) Nd:Glas





Commercially available: Phosphate and Silicate glasses: Rods up to 7.5 cm x 2m Discs up to 90 cm x 5 cm

Phosphate glasses have 50% higher stimulated emission cross section t ($\sigma = 3.7-4.5 \times 10^{-20} \text{ cm}^{-3}$)

Lasermaterialien (4) Nd:Glas







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Absorption spectra of Nd in Silikate- (left) and Phosphate glasses (right)

Efficiency of laser pumping – flash lamps



(close coupled geometry).





Mirros form the resonator, often named "Laser Cavity" in contrast to "Pump Cavity", combining the pump source with the laser medium.

Efficiency of laser pumping – diode pumping



In addition to flash lamps laser diodes are used more often to pump laser material



Fiber coupled laser diode "End-pumped" geometry



Pump efficiency η_P



Converting the electrical power to the pump into useable pump radiation: Useable pump radiation: Radiation in the absorption band of the laser medium

 η_{p} = part of el. power into optical radiation in the absorption band of the laser material

 Laser diodes (array): If matched, typical 0.3-0.5 (cw-oder quasi cw)

• For flash lamps:
$$\eta_P = P_\lambda / P_{in} = \int_{\lambda_1}^{\lambda_2} P_\lambda' d\lambda / P_{in}$$

With P_{λ} as spectral output power into absorption band of the laser material P_{in} el. Input power and P_{λ} ' spectral radiating power and $\lambda_{1,2}$ the acceptance bandwidth to pump the upper laser level

Typical values for η_{p} are 0.04-0.08 for 5-10 mm thick laser material

Pump coupling efficiency- η_{t}

Transfer of radiation to the laser medium using the pump cavity.

Radiation transfer efficiency: η_{t}

 $\boldsymbol{\mathsf{P}}_{e} = \boldsymbol{\eta}_{t} \boldsymbol{\mathsf{P}}_{\lambda}$

with P_{λ} as usable pump power of the source and P_{e} the part transmitted into the laser medium

 η_t combines capture efficiency and transmission efficiency.

Capture efficiency: part of the radiation hitting the laser dep. on geometry of the pump cavity, diameter and distance of source and laser.

Transmission -Efficiency: Wall reflectivity of the pump cavity, absorption in cooling liquid, losses at cavity windows. $\eta_{_t} = (1-R)$

Typical values for close coupled cavities: $\eta_t = 0.3 - 0.6$ (less in high energy lasers)

Diode pump cavities can reach higher coupling efficiencies up to $\eta_t = 0.85 - 0.98$.

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Absorption of the pump radiation by the laser medium and transfer of the energy into the upper laser level.

- 2 Processes:
 - Absorption into Pump levels: η_a
 - Transfer of the energy from pump level into upper laser level: $\eta_0 \eta_s$

Absorption efficiency: ratio of absorbed power P_a into coupled power P_a

$$\eta_a = P_a / P_e$$

The efficiency of the upper laser level is defined as laser power per absorbed power into the pump levels. It consists of two factors:

Quantum efficiency η_{q} : number of laser photons devided by number of pump photons Quantum defect-efficiency or Stokes-Faktor η_{s} :

$$\eta_{S} = \left(\frac{hv_{L}}{hv_{P}}\right) = \frac{\lambda_{P}}{\lambda_{L}}$$

Ratio of photon energy of the laser light to photon energy of the pump light e.g.: Diode-pumped YAG: Pump: 808nm; laser 1064nm; η_s =0.76 und η_q =0.90.



Spatial overlap of TEM modes in the resonantor with pumped volume Part of the stored energy in upper laser level that can be used in the resonator.

 η_B resonator mode volume divided by pump volume Numbers smaller than 1 : part of the energy escapes by spontaneous emission. Mode-matching efficiency. Numbers vary between 0.1 und 0.95; TEM₀₀ typ. 0.3-0.5; TEM_{xx} typ. 0.8-0.9

 η_{F} part of the total stored energy in upper laser level that is emitted.

Numerous loss mechanisms, like:

$$\eta_E = \eta_{St} \eta_{ASE} \eta_{EQ} \qquad (3.34)$$

Mit η_{st} loss by fluorescence and straggling; η_{ASE} Loss by amplified spontaneous emission and η_{EQ} extraction efficiency e.g. of Q-switching.

UHI Lasers: only by mode locking



Phase correlation of longitudinal modes in the resonator

Idea: increase losses for all non-locked combinations. Those are of low intensity.



Mode-Locking



Passive mode-locking:

The KLM-Oscillator (Kerr-Lens-modelocking):



Switch by self – generated Kerr lansing and aperture

Intense light is passed through the aperture as suffers less losses.

Short pulses: Dispersion



According to the Fourier Theorem short pulses have a large bandwidth. All frequencies have a slightly different refractive index

The optical material hast normal dispersion in the visible and near IR range (for $\lambda_1 > \lambda_2$ yields: $n(\lambda_1) < n(\lambda_2)$) and creates positive chirp (d.h. $D_2 > 0$)

Mat.	n ₀	D ₀	D ₁ [fs]	D ₂ [fs ²]	D ₃ [fs ³]	D ₄ [fs ⁴]
Saphir	1.76019	138245	59387	580	421	-152
BK7	1.51078	118656	50888	446	320	-96
Quarz	1.45332	114143	48905	361	274	-102
SF14	1.74294	136890	59558	1783	1144	-250

Dispersion components for some optical media for $\lambda_0 = 800$ nm (central wavelength) and x = 1 cm (path in material)

To compensate positive Chirp we need optical arrangements to invoke negative ($D_2 < 0$)

Dispersion pulse lengthening



- •Dispersion effects are specifically strong for fs pulses (highest bandwidth)
 - •a 1-cm thick glass plate lengthen a 10-fs pulse to >100 fs
 - •a 1-m thick glass plate has no effect on a 1 ps long pulse



Mode-Locking



Passive mode-locking:

The KLM-Oscillator (Kerr-Lens-modelocking):



In a Kerr lens oscillator the pulse runs many times through the dispersive medium

Dispersion: compensation with prisms



•2 identical prisms exactly anti-parallel

 negative dispersion, as "blue" passes less material then "red"



•Calculations: optical path through arrangement and find resulting phase and D_m

$$\varphi = \frac{2\pi}{\lambda} \cdot s_{opt}(\lambda) = \frac{\omega}{c} \cdot s_{opt}(\omega) \quad D_m = \frac{\partial^m \varphi(\omega)}{\partial \omega^m}$$

Dispersion: compensation with gratings



- •2 identical gratings, exactly anti-parallel
- •d = 1/p = N = 1200-1800 l/mm
- •blazed gratings: $R_{1.0} = 90 98$ %

- •Characterized by:
 - •Incident angle α ,
 - •Grating distance D(for $\lambda = \lambda_0$)
 - •Grating equation for the first grating: sin α + sin β = N λ (see picture)



Short pulse oscillator



 Invention of the Kerr-Lens-Mode-locking (KLM) has revolutionized the short pulse laser busines

•By KLM we can create (< 5fs) relatively easy.

•Generic short pulse oscillator



Resonator Design



- •High non-linearity in Kerr medium: Medium in focus of the mirrors SPM.
- •Astigmatic compensated resonator (Sub cavity) made of 2 focusing and 2 planar resonator mirrors.
- •Dispersion management (here prisms).







Modern laser concerts archite are, Pulse shaping





Beam gets injected into main amplifier as boosters

Example: NOVA Laser









Amplifier Design





Example



Example of a multipass amplifier



Schematic descritption of the NIF Beamline without preamplifier

Idea: Multipass amplification including PEPC

regenerative amplification



•Beam is inserted and extracted actively



•Components:

- •End Mirrors: curved, high reflective, form a resonator
- •Amplifying medium often at Brewster angle (no losses for p-polarized light)
- •Polarizing beam splitter: transmission for p-polarized light >80%

reflectivity for s-polarized light >80%

for the entire bandwidth of the pulse

•Resonator:

- •Only resonator modes are amplified: great beam profile
- •Requires mode matched injection of the pulse

Features of a regen



On the spectrum:

- optical medium: many roundtripsäufe, high dispersion
- => for ultra short pulses (<25fs) a regenerative amplifier is fairly useless

Saturation effects: low spectral deformation if gainis low and J_{Sat} is not reached

Gain-narrowing, as losses require a higher total gain

Influence on pulses:

Amplifier in saturation: high energy yield Energy stable Square-Pulse-Distortion Pre-pulses



ASE noise

Example of a regen



Z-Beamlet (Sandia NL, Ca. USA)







Multipass Amplifier



Beam is sent through active material multiple times with different angles



Amplifier design with high potential, especially diode pumped

Coating issues in the past (multilayer coating)

Frontside AR coated for laser wavelength

Backside HR coated for laser wavelength

Backside transparent for pump light (hard for flash lamps)

Limit in aperture: Transverse lasing



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Disk Laser Principles

Pump Light Absorption



TRUMPF





TRUMPF Optical setup of cw disk laser **HR Mirror** Pump Unit Homogenizer Resonator Laser Disk w. impinchment cooling "Cooling finger" **OC Mirror** "Cavity" for efficient pump light absorption



Record performance: 10 kW per Disk / 62 % optical efficiency

→ There are no barriers to scale power/disk beyond current power levels





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Pump sources (flash lamps)



1700 A/cm²

0.8

0.9

1.0

0.3

0.4

0.5

0.6

0.7

Wavelength [µm]



7680 flashlamps, each 6 feet long 30 kJ energy each





Diodes can convert up to 60-70 of the electricity into radiation

Better spectral match to the laser medium absorption band: almost full conversion of the diode light into population inversion

Individual emitters: very small (200µm-1mm wide and 0.4 µm high, 500µm length).

Emitted radiation different in divergence => matching optics

1cm Diode bars ca. 10 – 50 independent emitters.

Small size limits the power via damage threshold of the micro optics in the resonator

Pump sources (Laser diodes)





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Pump sources (Laser diodes)



2-D array



Diode array 1kW from 4 cm² surface

Pulsed array with 30% duty cycle

Peak power up to 30 kW And cw power up to several kW





6. Moderne Laserkonzepte, Architektur, Pulsformung



Laser system (132 W; 1 kHz) JAERI: 1.5 x 1m Footprint

Pulse from oscillator double pass through $\lambda/4$ plate; magnified and filtered image relayed; 2 double pass with Faraday-Rotator (compensate thermal biefringence);

SBS cell reflects the pulse 3. time into amplifier (double pass)

In SBS cell pulse phase conjugated (phase distortions compensated)

ZigZag Nd:YAG amplifier (5mm X 25cm; 0.85%);

2 pump arrays 9kW peak power in 200µs pulses

Other important effects



Heat management and thermal effects



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Other important effects

Wavefront distortions

- •A thin mirror can deformed by micro-actuators
- •Deformable mirrors have been invented for SDI, astronomy and later biology
- •Deformable mirrors are used for the last 25 years in lasers successfully







Temporal contrast



The interaction of a laser pulse with the target can start way before the arrival of the main pulse die



Topology of a laser pulse



- 1. Deviation of ideal temporal shape (spectral phase)
- 2. Coherent contrast (origin not quite clear, maybe surface roughness)
- 3. ASE in preamplifiers (3a) and main amplifier (3b)
- 4. Pre pulses in ps range (4a) and nanoseceond range (4b)





ASE: Amplified Spontaneous Emission

$$\frac{A}{R} \propto \omega^3$$

Improvement on pre pulse contrast



Pulse picker (Pockels Cell)
Dependend on TFP efficiency is 10⁻² to 10⁻⁴
Time to switch up to 0.1 ns



Improvement for CPA systems



In CPA systems pulse picker cannot be used below a nanosecond stretched pulse and ASE overlap

Solution:

Pulse is amplified in a first stage, compressed, cleaned and stretched again

Double CPA concept cleaning by non-linear effects

XPW (Kerr-effectt based tilt of polarization) saturable absorbers



end

